FORM PTO-1449 (REV. 7-80) (Title Amended 3/83)

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.	SERIAL NO.
125649-1	10/681,767

Applicant: DOUGLAS ALBAGLI, ET AL

Filing Date	Group
10/06/03	2878

INFORMATION DISCLOSURE STATEMENT BY APPLICANT--
LIST OF ITEMS

(*Use several sheets if necessary*)

APR 19 2004 JC26 PATENT & TRADEMARK OFFICE

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
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	AH						
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	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	TRANSLATION No
F.P.	AL	03071307	08/28/03	WIPO				
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (*Including Author, Title, Date, Pertinent pages. Etc*)

	AR	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
F.P.	AA	6031234	02/29/00	ALBAGLI, ET AL			
	AB						
	AC						
	AD						
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	AF						
	AG						
	AH						
	AI						
	AJ						
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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	TRANSLATION No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (*Including Author, Title, Date, Pertinent pages. Etc.*)

F.P.	AR	S. D. THEISS, ET AL "POLYSILICON THIN FILM TRANSISTORS FABRICATED AT 100 DEGREES C ON A FLEXIBLE PLASTIC SUBSTRATE", ELECTRON DEVICES MEETING, 1998, IEEE, IEDM TECHNICAL DIGEST, PP. 257-260.
	AS	
	AT	

EXAMINER	DATE CONSIDERED
[signature]	6/27-05

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